

REMARKS

The Examiner, in the Examiner's Statement of Reasons for Allowance, cites new prior art, not previously applied --US 6,787,621 (Kim et al)¹; JP05-232623 (Yukio et al); JP08-069083 (Shinichi); and JP09-311356 (Takeshi et al)-- and states as reasons for allowance that the ring L of the present claims does not contain a substituent, while the optical recording media of the above prior art "contain multiple substitutions throughout the ring."

However, Applicants describe in the specification at the paragraph bridging pages 23 and 24 that hydrogens on ring L may be substituted. Thus, the Examiner's statement of reasons for allowance interprets the scope of the allowed claims in a manner inconsistent with and narrower than Applicants' intended scope and meaning for ring L.

Applicants respectfully call the Examiner's attention to the Information Disclosure Statement (IDS) filed March 16, 2005. The Examiner is respectfully requested to initial the Form PTO 1449 submitted therewith, and include a copy thereof with the next Office communication.

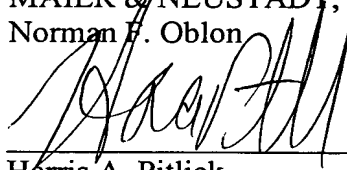
¹ Kim et al is not prior art because its prior art date of September 19, 2002 is after Applicants' international filing date of August 27, 2002.

Application No. 10/787,375
Reply to Examiner's Statement of Reasons for Allowance

The application is again now ripe for examination on the merits. An early examination is respectfully solicited.

Respectfully submitted,

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